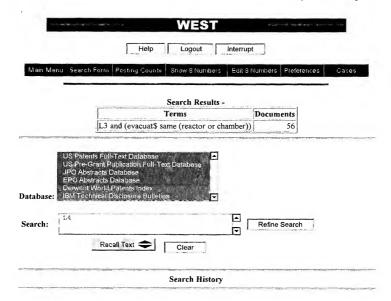
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	Search Results -	
	Terms	Documents
	L3 and (evacuat\$ same (reactor or chamber))	56
EPO / Derwe	ostracts Database obstracts Database ont World Patents Index ochnical Disclosure Bulletins	

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Set Name side by side	Query	Hit Count	Set Name result set
DB-USP1	T,PGPB,JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP ADJ		
<u>L4</u>	L3 and (evacuat\$ same (reactor or chamber))	56	<u>L4</u>
<u>L3</u>	L2 and (flux near5 electron)	177	<u>L3</u>
<u>L2</u>	L1 and (CVD or chemical vapor deposition)	51188	<u>L2</u>
<u>L1</u>	(438/\$ OR 427/\$ OR 118/\$).CCLS.	320658	<u>L1</u>

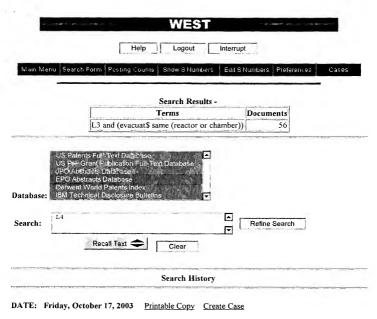
END OF SEARCH HISTORY



DATE: Friday, October 17, 2003 Printable Copy Create Case

Set Name side by side	Query	Hit Count	Set Name result set
DB=USP7	T,PGPB,JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP=ADJ		
<u>L4</u>	L3 and (evacuat\$ same (reactor or chamber))	56	<u>L4</u>
<u>L3</u>	L2 and (flux near5 electron)	177	<u>L3</u>
<u>L2</u>	L1 and (CVD or chemical vapor deposition)	51188	<u>L2</u>
<u>L1</u>	(438/\$ OR 427/\$ OR 118/\$).CCLS.	320658	<u>L1</u>

END OF SEARCH HISTORY



Set Name	Query	Hit Count	Set Name
side by side			result set
DB=USPT	T,PGPB,JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP~ADJ		
<u>L4</u>	L3 and (evacuat\$ same (reactor or chamber))	56	<u>L4</u>
<u>L3</u>	L2 and (flux near5 electron)	177	<u>L3</u>
<u>L2</u>	L1 and (CVD or chemical vapor deposition)	51188	<u>L2</u>
<u>L1</u>	(438/\$ OR 427/\$ OR 118/\$).CCLS.	320658	Li

END OF SEARCH HISTORY